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Docket No.: 3449-0407PUS1
(PATENT)

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of:
Suk Hun LEE

Application No.: 10/516,742

Confirmation No.: 6987

Filed: December 6, 2004

Art Unit: 2812

For: NITRIDE SEMICONDUCTOR AND
FABRICATION METHOD THEREOF

Examiner: C. Lee

AMENDMENT IN RESPONSE TO FINAL OFFICE ACTION

MS AF
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

INTRODUCTORY COMMENTS

In reply to the outstanding Office Action dated October 10, 2006, the following amendments and remarks are respectfully submitted in connection with the above-identified application.

This reply includes: An Amended Set of Claims; and
Remarks.